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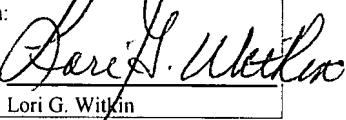


Docket No.: TLO-2-PCT/US/Minori

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450; Alexandria, VA 22313-1450, on:

April 2, 2007
(date)



Lori G. Witkin

In re: Application of: Tetsuro TAKAMATSU, et al.

Serial No. : 10/540,600 Group Art Unit: 2874

Filed : June 24, 2005 Examiner: T. Wong

For : MULTILAYER OBSERVATION OPTICAL MICROSCOPE
AND MULTILAYER OBSERVATION UNIT

New York, New York
April 2, 2007

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated January 3, 2007, reconsideration of the outstanding rejections is respectfully requested in view of the remarks beginning on page 2 herein, please amend this patent application as follows: